



AFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Takahiro
Arakida

Application No. 10/826,085

Filed: April 16, 2004

For: MULTIPLE WAVELENGTH
SEMICONDUCTOR LASER AND
MANUFACTURING METHOD THEREOF

Group Art Unit: 2828

Examiner: To be assigned

CERTIFICATE OF MAILING

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December 2, 2005

Suzarah Guevara
Suzarah Guevara

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY

Sir:

With regard to the above-identified patent application that was filed in the U.S. Patent and Trademark Office on April 16, 2004, U.S. Serial No. 10/826,085, we have not yet received any communication from the U.S. Patent Office since issuance of the Notice of Publication of Application which was dated November 25, 2004. At this time, we respectfully request the current status of this application.

Dated: December 2, 2005

Respectfully submitted,
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